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Date : May 3, 2006  
TO : Director, Office of Patent Publication  
FROM : Office of Petitions  
SUBJECT : Withdrawal from Issue of **Application No. 10/623,581**

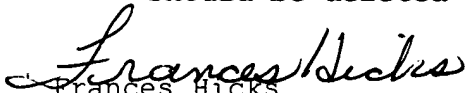
Applicant(s) : Isamu Kobori et al  
Application No. : 10/623,581  
Filed : July 22, 2003

The above-identified application has been assigned Patent No. 7,041,587 and an issue date of May 9, 2006.

It is hereby directed that this application be withdrawn from issue at the request of the applicant. Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of May 9, 2006:

"All reference to Patent No. 7,041,587 to Isamu Kobori et al of Japan for METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM TRANSISTOR appearing in the Official Gazette of May 9, 2006 should be deleted since no patent was granted."

  
Frances Hicks  
Petitions Examiner  
Office of Petitions

cc: Paul Harrison  
Deneise Boyd  
Mary Louise McAskill  
Niomi Farmer  
Mary E. Johnson (Cookie)  
Duane Davis (CDS)